



JFW

PATENT
8001-1190

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Tatsuya USAMI Conf. 4182

Application No. 10/766,886 Group 2811

Filed January 30, 2004 Examiner Nitin Parekh

SEMICONDUCTOR DEVICE HAVING COPPER
DAMASCENE INTERCONNECTION AND
FABRICATING METHOD THEREOF

AMENDMENT

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 8, 2005

Sir:

Responsive to the Official Action of February 8, 2005,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

An **Appendix** is attached following the signature page of
this paper.